



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



CONFIRMATION NO. 7150

Bib Data Sheet

SERIAL NUMBER 10/716,612	FILING DATE 11/20/2003 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 4717-7700
-----------------------------	-----------------------------------	--------------	------------------------	-------------------------------------

## APPLICANTS

Walter Schwarzenbach, Saint Nazaire les Eymes, FRANCE;

Jean-Marc Waechter, Saint Vincent de Mercuze, FRANCE;

\*\* CONTINUING DATA \*\*\*\*\* *None/TSP*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Yes/TSP*  
FRANCE 0214864 11/27/2002

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 03/01/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged	Examiner's Signature Initials	FRANCE	3	23	2

## ADDRESS

28765  
 WINSTON & STRAWN LLP  
 1700 K STREET, N.W.  
 WASHINGTON , DC  
 20006

## TITLE

Annealing process and device of semiconductor wafer

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )
RECEIVED 954		